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CONFIRMATION NO. 1598

<b>SERIAL NUMBER</b> 10/586,788	<b>FILING or 371(c) DATE</b> 09/02/2008 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2893	<b>ATTORNEY DOCKET NO.</b> INF 2006 VJ 33543 US		
<b>APPLICANTS</b> Zvonimir Gabric, Zorneding, GERMANY; Werner Pamler, Muenchen, GERMANY; Guenther Schindler, Muenchen, GERMANY; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/DE05/00088 01/22/2005 <b>** FOREIGN APPLICATIONS *****</b> GERMANY 10 2004 003 337.4 01/22/2004 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 09/04/2008						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/NIKOLAY K YUSHIN/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> GERMANY	<b>SHEETS DRAWINGS</b> 4	<b>TOTAL CLAIMS</b> 17	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> SLATER & MATSIL LLP 17950 PRESTON ROAD SUITE 1000 DALLAS, TX 75252 UNITED STATES						
<b>TITLE</b> Plasma Excited Chemical Vapor Deposition Method Silicon/Oxygen/Nitrogen-Containing-Material and Layered Assembly						
<b>FILING FEE RECEIVED</b> 1160	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		